

ABSTRACT

The present invention concerns an apparatus and method for absorbance detection in instrumental situations which have short absorption path lengths,

such as microchip type devices. By modulating the sample beam incident upon
5 a sample cell, the sensitivity of the absorbance measurement is improved. The
modulation means includes a scanning device arranged to move the sample
beam from a first position in which the sample beam is incident upon said
sample area to a second position in which the sample beam is incident upon
10 the cell.

Figure 1.